



EPW

PATENT
Attorney Docket No.: SAM-0483

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jae-eun Park, *et al.* Examiner: Nguyen, Tuah H.
Serial No.: 10/782,094 Group Art Unit: 2813
Filing Date: February 19, 2004
Title: METHOD FOR FORMING SILICON DIOXIDE FILM USING SILOXANE :

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.

10-5-05

Date

Vanessa Marakas

Vanessa Marakas

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

The following is in response to the Office Action mailed September 29, 2005 and is filed within the shortened statutory period of one month.

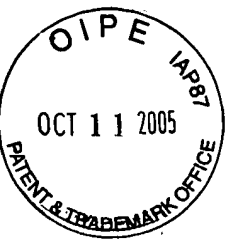
In response to the Restriction Requirement, the Applicant notes that Group I, claims 55-57 were canceled by Preliminary Amendment filed on February 19, 2004 with the application papers. Accordingly, Applicant elects Group II claims without traverse. Applicant further respectfully requests consideration of the Preliminary Amendment filed February 19, 2004 prior to prosecution on the merits of the present application.

Respectfully submitted,

Date: October 5, 2005
MILLS & ONELLO LLP
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Boston, MA 02108
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PATENT
Attorney Docket No.: SAM-0483
Customer No.: 29344

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Alexandria, Virginia 22313-1450

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following:

1. Response to Restriction Requirement mailed on September 29, 2005; and
2. Return Postcard.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: October 5, 2005
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